



PATENT  
Attorney Docket No. 04329.3238

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
)  
Gaku MINAMIHABA et al. ) Group Art Unit: 2818  
)  
Application No. 10/771,060 ) Examiner: Goodwin, David J.  
)  
Filed: February 4, 2004 ) Confirmation No.: 2231  
)  
For: POLISHING PAD AND METHOD OF )  
MANUFACTURING )  
SEMICONDUCTOR DEVICES )

Mailstop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**AMENDMENT**

In reply to the Office Action mailed January 23, 2007, the period for response to which having been extended to May 23, 2007, by a Petition for Extension of Time of one month and fee payment filed concurrently herewith, please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims in this paper.

**Remarks/Arguments** follow the amendment section of this paper.